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Electrical and Structural Characterization of Fired SnO₂ Thick Films by Screen Printing Technique

R. M. Nikam¹, K. H. Kapadnis², R. Y. Borse³

¹Department of Chemistry, M. J. M. ACS College, Karanjali, Tal- Peth, Dist-Nashik-422 208,

²Department of Chemistry, L. V. H. ACS College, Panchavati, Dist-Nashik-422 003,

³Department of Physics, M. J. M. ACS College, Karanjali, Tal- Peth, Dist-Nashik-422 208.

Abstract: Thick films of SnO₂ were prepared by Standard Screen printing method on glass substrates and films are annealed at 450^oC in air atmosphere. Electrical characterization was studied in static system. This paper revealed that SnO₂ is n-type semiconductor obeying negative temperature coefficient (NTC) characteristics. Thick films of SnO₂ were characterized by SEM, EDAX, XRD, FTIR and UV to study surface morphology, elemental analysis, crystalline Phases of films, vibrational and optical modes respectively.

Keywords: Thick Films, Screen printing method, XRD, SEM, EDAX.

I. INTRODUCTION

The air is a mixture of different pollutant gases. Nowadays in order to monitor these gases different techniques are used. Micro-sensors constructed with SnO₂ material is found to be more versatile because of its use in transistors, electrodes, gas sensors, liquid crystal displays, catalysts, photovoltaic devices, photo sensors, antistatic coatings, polishing and ceramic glazes [1]. Tin oxide is useful due to high degree of transparency in the visible spectrum, low operating temperature, strong thermal stability and more stable in higher oxidation state (+4) thereby a good oxidising agents in organic synthesis. Tin oxide is colourless, diamagnetic and amphoteric solid with n-type semiconductor having wide band gap 3.7 eV [2]. Krishnakumar. T. et. al., have reported that tin oxide exist as tetragonal (SnO₂) cassiterite oriented in most sharp XRD peak (110) in mineral form and rhomarchite (SnO) form oriented in most sharp XRD peak (101). Tin oxide semiconductor has space group P4₂/mmm and unit cell parameters are a=4.737 Å, c=3.185 Å [3]. In crystal lattice of SnO₂, Sn⁴⁺ ions are six co-ordinated octahedrally surrounded with three co-ordinated trigonal planer O²⁻ ions.

II. LITERATURE SURVEY

Tin element 50 hides everywhere in our nature often in movie relics: from *The Wizard of Oz's* Tin Man to tin can radio often spotted in tree houses. It exist in crystalline β and brittle α form at low temperature, two other exist at high temperature and pressure [4]. Nanostructured material has been extensively applied in technological applications because of their novel characteristic electronic, optical and mechanical properties and unique shape [5]. Gas sensitive materials of metal oxide having porous structure of thick films have been extensively studied and implemented for their gas response to oxidising and reducing gases. Practical gas sensors are made up porous material such as SnO₂, ZnO, WO₃, In₂O₃ etc. Among all tin oxide (SnO₂) of tetragonal phase material is universally accepted gas sensor [6].

It provides a high surface volume ratio and exact mechanism of gas sensing based on adsorption-desorption phenomenon. Tin oxide blended with other metal oxide i.e. binary oxide solid mixtures are found be more versatile than doped with noble metal and single counterpart. Semiconductor based chemiresistors are mostly investigated known as chemiresistive gas sensors. These fabricated sensors have excellent sensitivity, very short response time and low cost [5-6].

III. EXPERIMENTAL

A. Preparation of SnO₂ Thick Films:

Tin-oxide thick films were prepared on glass substrate with particular dimension by using standard screen-printing technique [7-13]. The SnO₂ powder (99.99 %) of loba grade was weighed and dried in air at 450^oC for 5 hr. The calcined SnO₂ powder was mixed and crushed thoroughly with glass frit acts as permanent binder and ethyl cellulose acts as a temporary binder. The mixture was then mixed with butyl carbitol acetate as organic vehicle to form the paste. The paste was then screen printed onto the surface of glass substrate. The details of the technique are described elsewhere [9]. After screen printing the films were dried under IR- lamp for 1 hr. and then fired at 450^oC for 5 hrs. The thickness of the films was observed in the range of 20μm–30μm.

1) *Electrical Measurement*

The resistance of the thick film sample was measured by using half bridge method at different temperatures in air. Variable DC power supply (APLAB 0-30V, 2A) is used to enable the user to choose the required voltage; the voltage across the standard reference resistance was measured by digital multimeter. The thick film samples were heated slowly to avoid any thermal runaway. At the selected interval of temperature voltage across the reference resistance was noted. The resistance of thick film sample was calculated by using the Equation 1.

$$R_{\text{sample}} = R_{\text{ref}} \left[\frac{V_{\text{supply}}}{V_{\text{ref}}} \right] \dots\dots\dots(1)$$

Where, R_{sample} –Resistance of thick film,
 R_{ref} –Resistance of Standard reference resistance,
 V_{supply} – Applied voltage,
 V_{ref} –Reference voltage across standard resistance.



Fig.1. Schematic diagram for static measurement system

2) *Structural and Morphological Studies*

Using X-ray diffraction (Miniflex Model, Rigaku, Japan) analysis from 20-80, 2θ was carried out to examine the phases of the SnO_2 films samples. The instrumental broadening was removed using silicon standard sample. The single line approximation method has adopted for the crystallite size determination using most intense peak. The average grain size of tin oxide thick film sample was calculated by using the Scherer formula [14]:

$$D = \frac{0.9\lambda}{\beta \cos\theta} \dots\dots\dots(2)$$

Where, D- is the average grain size,
 λ -1.542 Å (X-ray wavelength),
 β - the peak FWHM in radiation,
 θ -diffraction peak position.

The microstructure and chemical composition of the films were analyzed using a scanning electron microscope [Nova nano SEM NPEP303] coupled with an energy dispersive spectrometer (EDS JEOL, JED-2300, Germany). In FTIR analysis, the IR spectra have been recorded in the range of frequencies 500-5000 cm^{-1} . FTIR spectra were recorded using PERKIN ELMER instrument using KBr pellets (1% Wt/Wt) with spectral resolution of 2 cm^{-1} and taking 32 scans for each sample. UV analysis was performed in SHIMADZU UV-2600 UV-VIS Spectrophotometer with wide range of 200-800 nm with single scan mode and fast scan speed.

IV. RESULTS AND DISCUSSIONS

A. *Structural Characteristics*

1) *X-ray Diffraction Analysis:* In Order to understand the crystalline phases in SnO_2 thick film samples, the X-ray diffraction study was undertaken. XRD analysis was performed using $\text{CuK}\alpha$ radiation of wavelength $\lambda=1.54\text{\AA}$ at accelerating voltage of 40 kV and 40 mA current in continuous scan mode with 15 degree/min used for phase and crystal structure study of the deposited thick films at room temperature. Fig. 2 shows an XRD pattern of SnO_2 film samples plotted in the range 20-80 (2θ) verses intensity having several peaks of tin oxide phases showing polycrystalline nature. Peaks are observed at the angular positions: $2\theta= 26.94, 34.26, 38.34, 38.48, 52.1, 55.1, 62.22, 65.04$ and 66.22 which were indexed to the (110), (101), (200), (111), (211), (220), (310), (112) and (301) respectively. The observed peaks match well with the reported data of Tin-oxide (JCPDS Card No. 41-1445) confirming the polycrystalline nature. The higher peak intensities in XRD pattern at $2\theta=26.94$ is due to the better crystallinity and bigger grain size can be attributed to the agglomeration of particles. The narrow and sharp peaks reveal that SnO_2 compositions are well crystallized. The crystallite size of highly crystalline peak indexed at (110) is found to be 115.04 nm. The average crystallite size was calculated Using Scherer equation and was estimated to be about 93.34 nm.

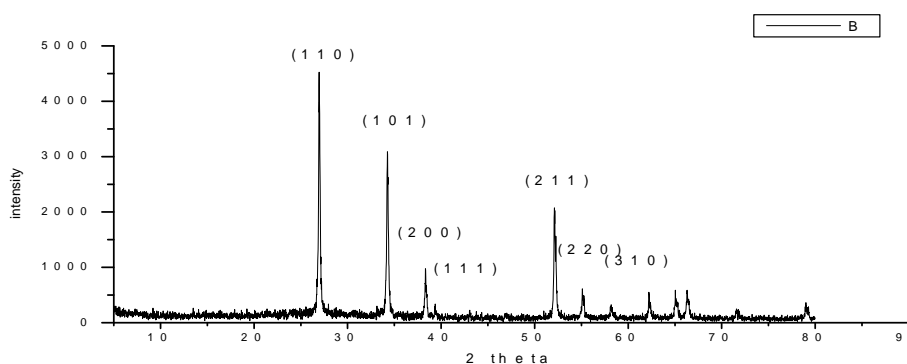


Fig.2. XRD pattern of SnO₂ film sample fired at 450⁰C

Table 1. Indicates XRD parameters

2θ	FWHM	planes	Crystallite size in nm
26.94	0.071	110	115.04
34.26	0.165	101	50.37
38.34	0.094	200	89.46
38.48	0.071	111	118.49

2) *Scanning Electron Microscopy*: Scanning electron microscopy is sophisticated technique to study the microstructure of thick film samples. Fig. 3 shows the surface morphology of SnO₂ films observed by SEM. SEM image is recorded at 200000x magnification range with 15 kV accelerating voltage for SnO₂ thick film sample fired at 450⁰C. The micrograph of this sample shows voids between the particles, basically due to evaporation of the organic solvent during the firing of the film. The average calculated particle diameter in this micrograph is around 45.53 nm. More agglomeration in the film samples are observed in tin oxide micrograph which will be better for gas sensing study in future.

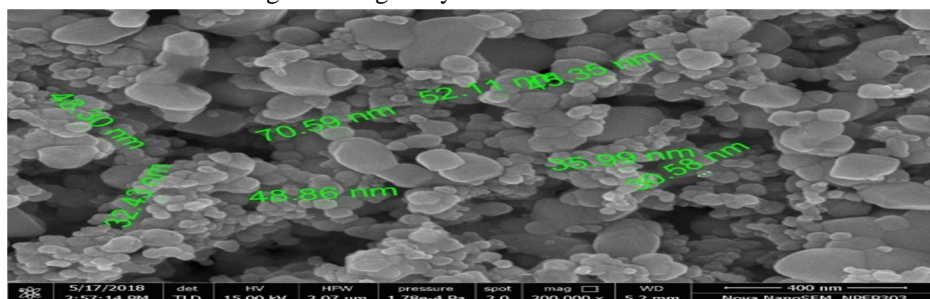


Fig 3. SEM image of SnO₂ thick film

3) *Energy Dispersive X-Ray Analysis*: The EDX analysis always used to examine the composition of the film materials through qualitative and quantitative approach with 1000 ppm detection limit or 0.1% wt. The thick film SnO₂ was coated with sputtered platinum with 2-3 nm. Fig.3 illustrates the composition of SnO₂ thick film. It is seen that the major peaks observed are of tin and oxygen and no other impurity present in the tin oxide composition. Also the spectra reveals that weight % and atomic % are nearly matched as illustrated in table no .2.

Table-2: Quantitative elemental analysis

Element	Series	Wt. %	At. %
Sn	L-series	72.33	26.05
O	K-series	27.67	73.95
	Total	100.00	100.00

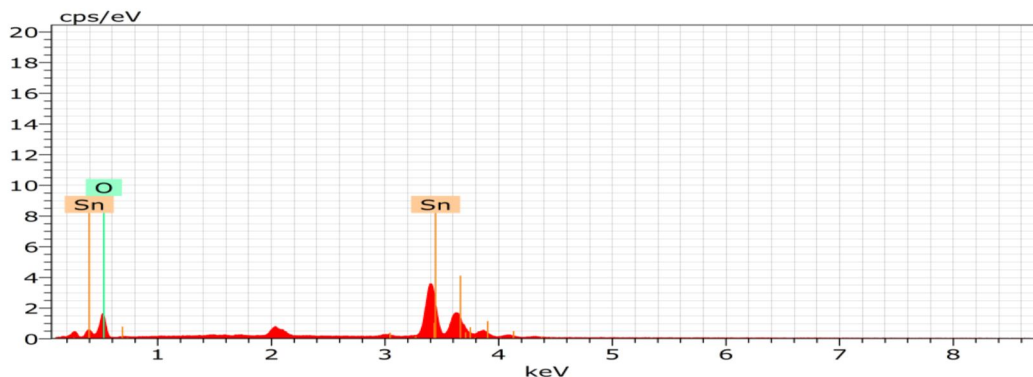


Fig. 4. EDAX curve of SnO₂

4) *Ftir Analysis:* The absorption band at 3734 cm⁻¹ is due to attribution of asymmetric hydroxyl stretching mode of (O-H non bonded) vibration of surface hydroxyl group or adsorbed water[15]. IR band at 2949 cm⁻¹ is due to C-H bond is observed. An important characteristic peak is observed at 1514 cm⁻¹ an overtone of asymmetric stretching mode of surface bridging oxide formed by condensation of adjacent surface hydroxyl groups Sn-O-Sn atomic linkages. 675 cm⁻¹ is due to stretching frequency O-Sn-O atoms where vibrations and lattice modes were observed[16].

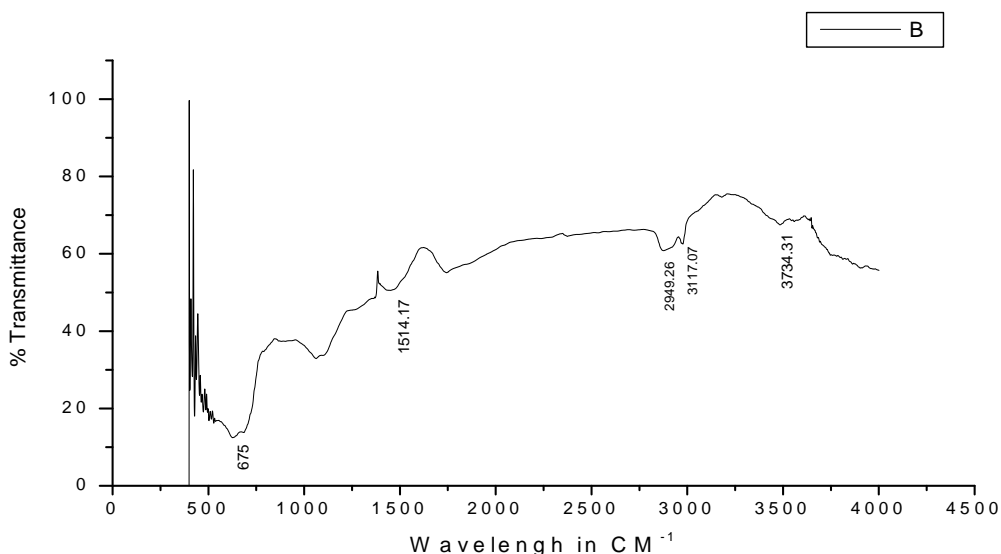


Fig 5. FTIR spectra of SnO₂

5) *UV Analysis:* Optical absorption spectroscopy is most traditional method by which quantum effects in semiconducting nanomaterial can be studied. Optical absorption analysis has been extensively proven to be a vital and active tool in interpreting the increase or decrease of energy gap and thereby progress of discrete characteristic in the spectra can be revealed. Thus study of optical properties of material is important due to capability of technique to give information in the electronic band, structures, localized states, Trapping levels and electronic transitions. For absorption study, a sample of 10 mg SnO₂ powder is dissolved in 10 ml water solution (1N H₂SO₄ solvent) to prepare 1000 ppm or 10 µg/ml concentration. The band gap of SnO₂ was calculated following tauc's equation 3,

$$E_g) \quad (\alpha h\nu)^{1/n} = A(h\nu - \dots) \quad (3)$$

Where E_g is the band gap, A is energy independent constant, n=1/2 for direct band gap of material, α is absorption coefficient, hν is incident photon energy where h is Planck's constant and ν is frequency. The extrapolated linear portion to horizontal axis of the tauc's plot gives value of band gap. The calculated band gap value is 3.18 eV which attributes to red shift. The absorption edge in SnO₂ material arises due to larger grain size, thermal effects and reduction in thickness of the film[17].

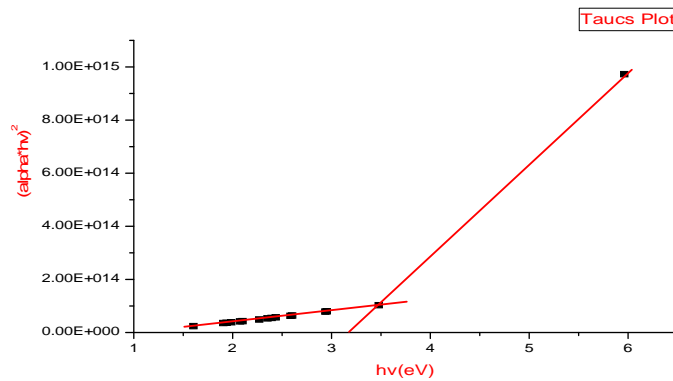


Fig 6. UV spectra of SnO₂

B. Resistance Measurement

1) *NTC Characteristics:* Fig. 7 shows the resistance variation of the SnO₂ thick film as a function of temperature. In the low temperature range (room temperature to around 280 °C), a decrease in resistance was observed as increasing the temperature due to the release of the carriers [16]. The tin oxide nanoparticles were having the conductivity even at low temperature also due to the migration of charged species like O²⁻, O⁻, OH⁻ and H₃O⁺ [18].

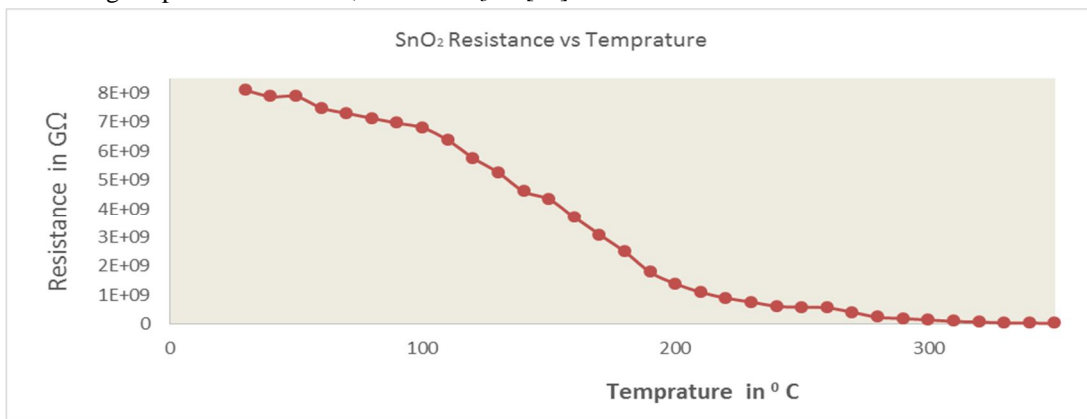


Fig 7. Indicates the NTC Charectristics of SnO₂ Base material

2) *Activation Energy graph:* The activation energy of the electron transport in coduction band is determined from arrhenius plot log R vereses 1/T. following graph indicates that curve has two distinct regions of low and high temperature region.

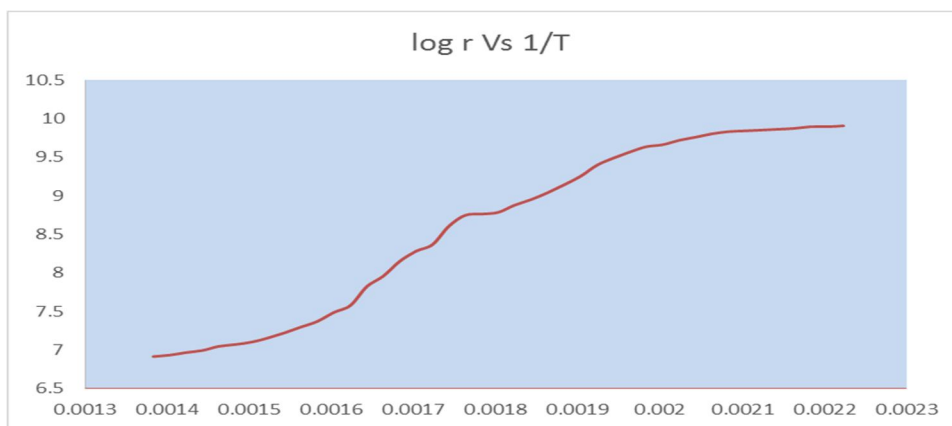


Fig 8. Indicates the arrhenius plot of SnO₂ Base material

V. CONCLUSION

The thick film of SnO₂ prepared by screen printed method fired at high temperature (450⁰C) give rise to new characteristic properties in nanomaterial rather than bulk one or macro level. The XRD data shows high degree of polycrystalline nature with average crystallite size 93.34 nm. SEM micrograph depicts particle size about 45.52 nm. The elemental data is well concurrent with standard composition of SnO₂ in terms of atomic and weight percentage. The IR spectra have been recorded in the range of frequencies 500-5000 cm⁻¹ which shows many broad bands between 2800-4000 cm⁻¹. Electrical characterization clearly indicates that at low temperature film resistance is high attributed to the thick films of SnO₂ prepared by standard screen printing method exhibit negative temperature coefficient. Ultraviolet absorption spectrum of pure SnO₂ shows that SnO₂ particles are monodispersed and shows broad absorption peak at 3.18 eV.

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